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10/540,992	06/05/2006	438	1792	061063-0316598
RULE				
APPLICANTS Jea Gun Park, Seognam-city, KOREA, REPUBLIC OF; Un Gyu Paik, Seoul, KOREA, REPUBLIC OF; Jin Hyung Park, Ulsan-city, KOREA, REPUBLIC OF; Takeo Katoh, Seoul, KOREA, REPUBLIC OF;				
** CONTINUING DATA ***** This application is a 371 of PCT/JP03/16813 12/25/2003				
** FOREIGN APPLICATIONS ***** REPUBLIC OF KOREA 10-2002-0087934 12/31/2002				
** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 07/21/2006				
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/MAKI A ANGADI/</u> Examiner's Signature	<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWINGS 10	TOTAL CLAIMS 17
			INDEPENDENT CLAIMS 1	
ADDRESS PILLSBURY WINTHROP SHAW PITTMAN, LLP P.O. BOX 10500 MCLEAN, VA 22102 UNITED STATES				
TITLE Chemical-mechanical-polishing slurry composition, method for planarizing surface of semiconductor device using the same, and method for controlling selection ratio of slurry composition				
FILING FEE RECEIVED 1030	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	